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TJK/189

IN THE UNITED STATES PATENT AND TRADEMARKS OFFICE

In re Application of: Chul-Ju Hwang et al.

) ATOMIC LAYER DEPOSITION
) METHOD AND
) SEMICONDUCTOR DEVICE
) FABRICATING APPARATUS
) HAVING ROTATABLE GAS
) INJECTORS

Filed: August 8, 2001

SUBMISSION OF CERTIFIED COPY OF PRIORITY DOCUMENTS

Assistant Commissioner for Patents
Washington, D.C. 20231
Box: Patent Applications

Sir:

Submitted herewith is the certified copy of the original Korean foreign application for the above referenced application based on a direct national filing in the U.S. on August 8, 2001. This U.S. application claims the priority from Korean application No: 2000.46216 filed on August 9, 2000 and meets the formality requirements set forth under 35 U.S.C. § 119.

Date: 8/16/01

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Respectfully submitted,

By: 

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CERTIFICATE OF MAILING

I hereby certify that this paper is being deposited with the United States Postal Service as first class mail in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231 on

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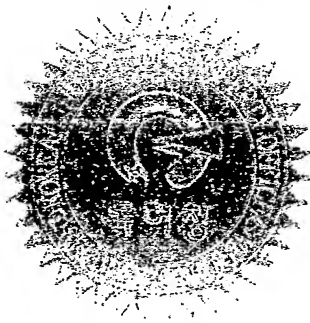
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This is to certify that the following application annexed hereto
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출원 번호 : 특허출원 2000년 제 46216 호
Application Number

출원 년 월 일 : 2000년 08월 09일
Date of Application

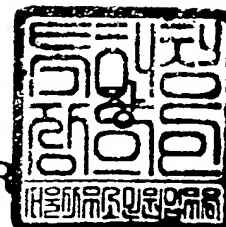
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Applicant(s)



2000 년 08 월 31 일

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